

Implementation of Linear Dark Field Control at the UA Wavefront Control Lab

Kelsey L Miller

PhD Candidate

University of Arizona

Steward Observatory & College of Optical Sciences

Adviser: Dr. Olivier Guyon

High Contrast Imaging on Segmented Apertures Workshop

NASA Jet Propulsion Laboratory

May 5 & 6, 2016

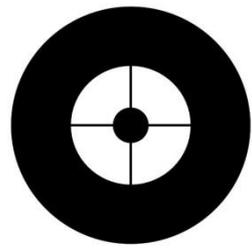
- Intro to LDFC
- EFC & LDFC Simulation Parameters
- Determining Linear Response
- Current Results
- Ongoing & Future Work

Intro to LDFC

- Purpose: To maintain 'dark hole' created by electric field conjugation without the need to continually re-implement EFC
- Procedure: Utilize the linear response of 'bright' pixels outside of the dark hole to changes induced in the pupil plane by the DM
- Goal of current work: Identify characteristics of bright pixels that can be used to close a linear control loop on the EFC dark hole
 - Linear range of pixel intensity response to DM actuation
 - Location of linear-response pixels with respect to dark hole
 - Null space of LDFC

EFC & LDFC Simulation Parameters

- Simulation of UA WFC testbed
 - $\lambda = 550\text{nm}$
 - Centrally-obscured pupil
 - f/39 system
 - Lyot coronagraph
 - 1024 actuator BMC Kilo DM (current)
 - 37 segment PTT111-L Iris AO (near-future)



- Dark hole specs:
 - Contrast $\sim 10^{-8} - 10^{-9}$
 - $4 \times 5 \lambda/D$ square region of interest
 - Located at $5 - 9 \lambda/D$ from PSF core

UA Wavefront Control Lab

- 1 Source
- 2 Pupil Mask
- 3 Iris AO DM/Optional Flat
- 4 Tip/Tilt Mirror
- 5 BMC DM
- 6 PIAA Lens Stage
- 7 Focal Plane Mask (FPM)
- 8 Lyot Stop
- A Science Camera
- B FPM Reflection Camera
- C Lyot Stop Reflection Camera

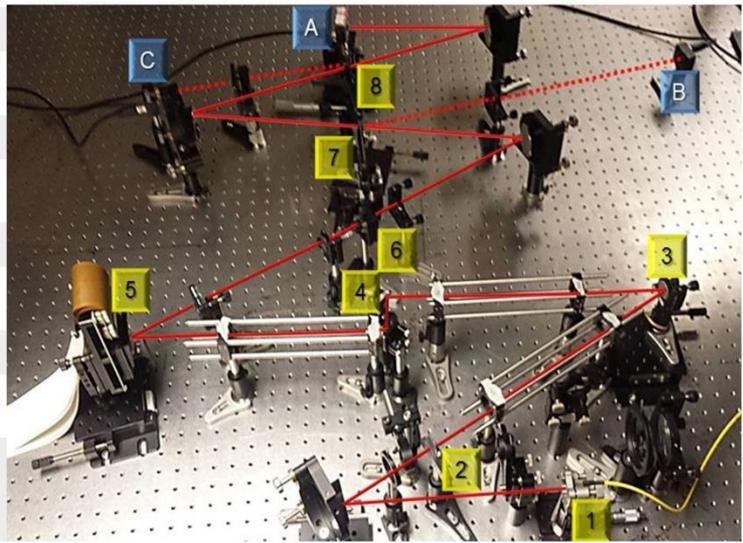


Fig. 1

Dark Hole $10^{-8} - 10^{-9}$ Contrast
(Simulation Log Scale)

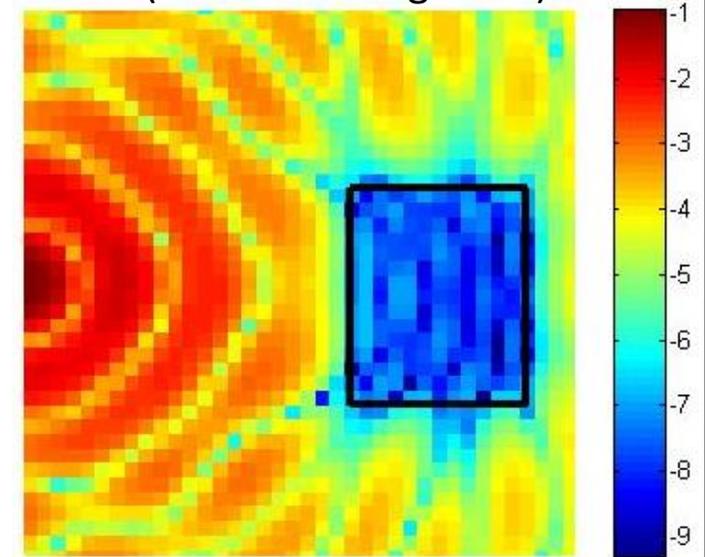
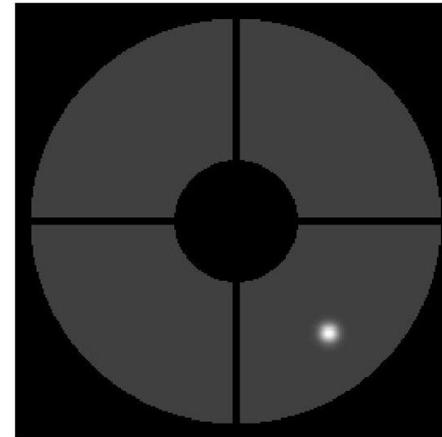


Fig. 2

Determining Linear Response

- Create 'dark hole' using DM
- Modulate single DM actuator over linear range of amplitudes: $[-A, +A]$
- Calculate intensity change $\Delta I = \text{PSF}_{\text{poked}} - \text{PSF}_{\text{ideal}}$ over the range of amplitude actuations on DM for all pixels in image
- ΔI over 156nm DM stroke range shown below for 5 dark hole pixels (plotted in Fig 4) and 5 bright pixels (plotted in Fig 6)



Pupil with poked DM actuator

Fig. 3

Dark Hole Pixel Response

Pixel Response: 7.859 - 8.943 λ/D

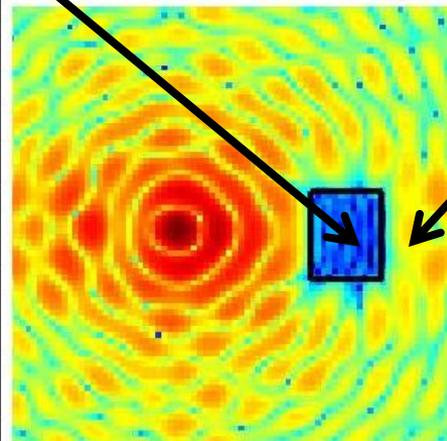
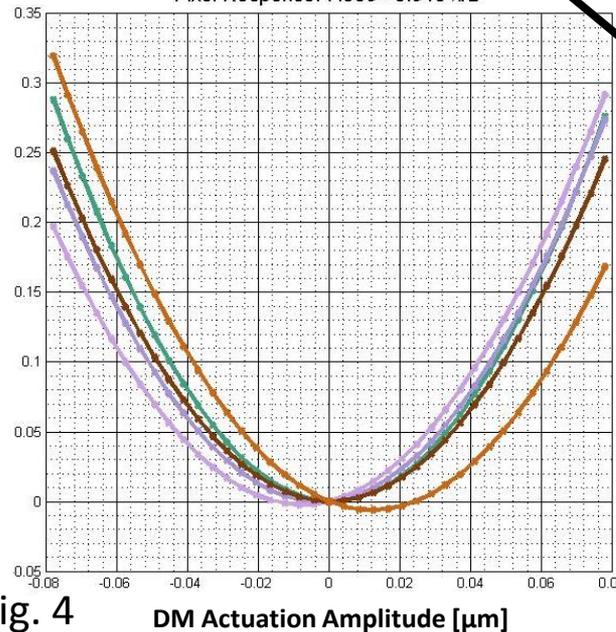


Fig. 5 (Log Scale)

Bright Pixel Response

Pixel Response: 11.924 - 13.008 λ/D

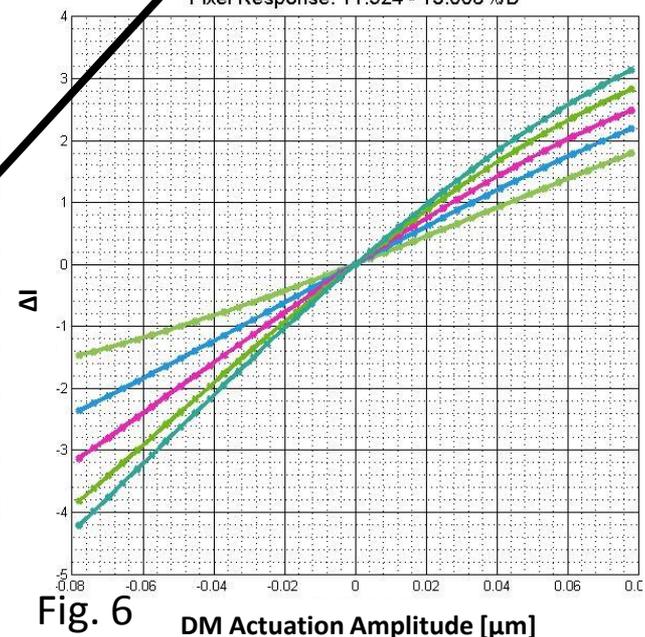
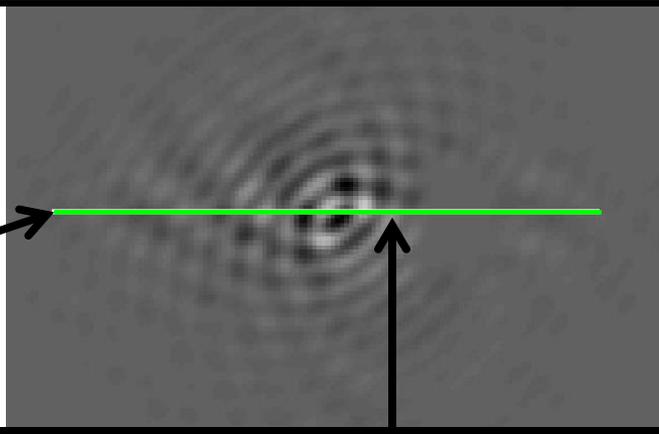


Fig. 6

Determining Linear Response

$\Delta I = \text{PSF}_{\text{poked}} - \text{PSF}_{\text{ideal}}$
and selected cross
section of pixels

Fig. 7



- For each pixel in a selected cross section, a linear least-squares fit to the ΔI response to the DM actuation is calculated.

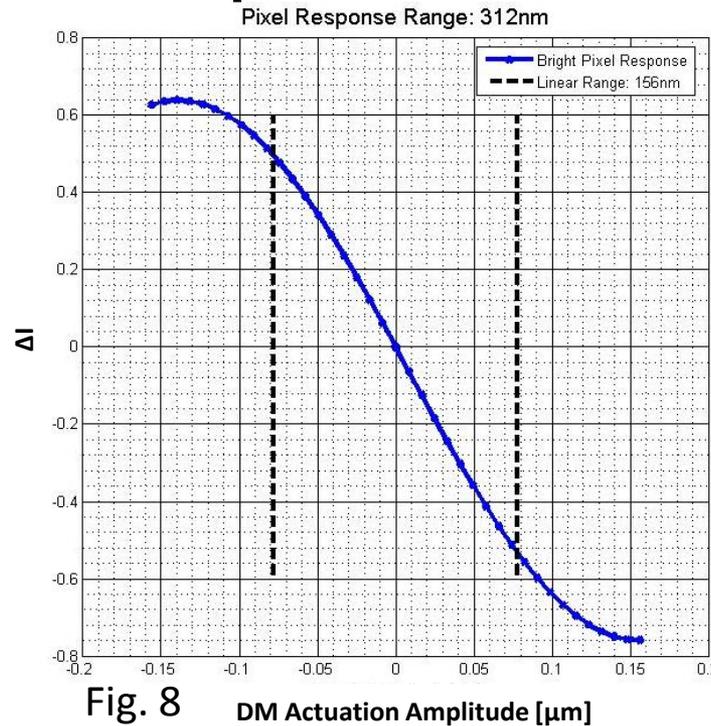
$$\beta = (\Delta I^T \Delta I)^{-1} \Delta I^T y$$

$$\Delta I = \text{pixel response}$$

$$y = \Delta I(\text{DM poke}_{\text{Amp } 1}) : \Delta I(\text{DM poke}_{\text{Amp } N})$$

- Linear fit metric: $0.97 < \beta < 1.03$

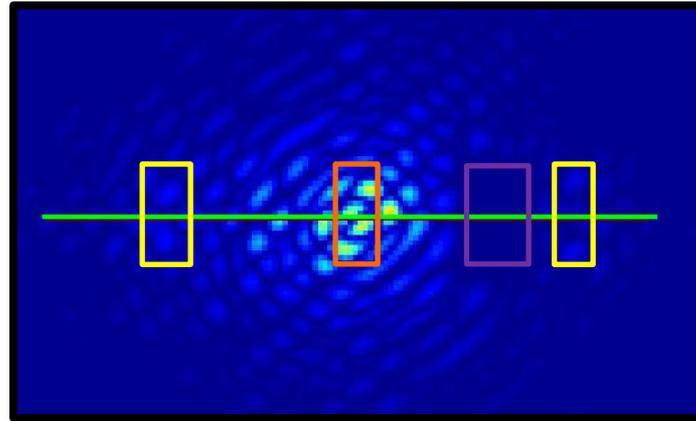
- Bright pixel response to linearly increasing DM stroke over 312nm range with amplitudes: [-156nm, +156nm]
- Shows linear bright pixel response over 156 nm DM stroke range with $\beta = 0.998$



- DM Actuation Linear Range: 156nm
- Bright Pixel ΔI Response to DM Actuation

Current Results

- Pixels with greatest absolute magnitude change in intensity $|\Delta I|$ show highly linear response.
- Results showing $|\Delta I|$ vs β shown below.

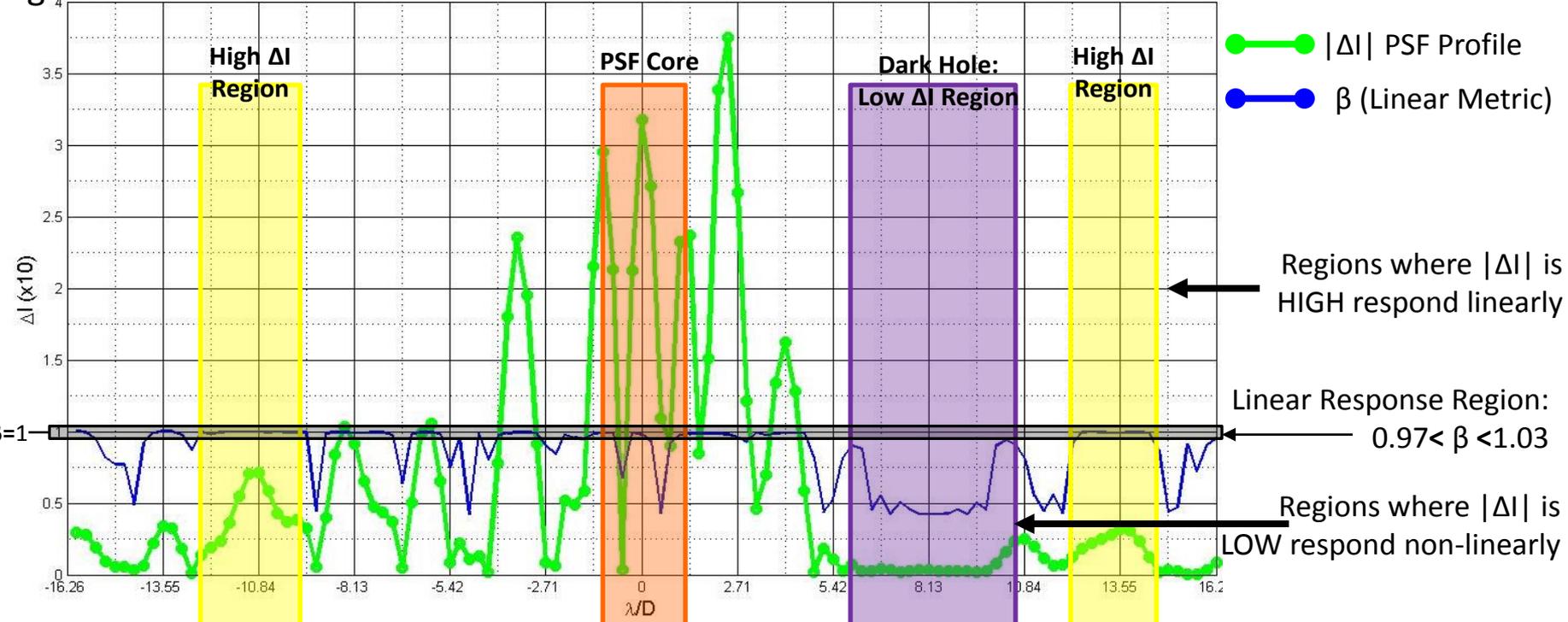


Profile of pixels selected for analysis across $|\Delta I| = |\text{PSF}_{\text{poked}} - \text{PSF}_{\text{ideal}}|$

Fig. 9

Fig. 10

Linear Response (β) Relative to PSF Pixel Intensity Change (ΔI) Over 156nm DM Stroke Range



Ongoing & Future Work

- Determine dependence of linearly-responding pixels on:
 - Location in the PSF wrt the 'dark hole'
 - Absolute change in intensity
- Map the null space of LDFC
- Build a control loop around linearly-responding pixels
- Apply to segmented Iris AO DM
- Implement on UA Wavefront Control Testbed